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SAM435-100/00656 Customer No.24,118

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: DONG-ILL CHO)
SERIAL NO: 09/614,785)
FILED: 07/12/2000)
FOR: SILICON ETCHING APPARATUS USING)
XeF2)
ART UNIT: 1746)
EXAMINER: PARVIZ HASSANZADEH)

AMENDMENT

Mail Stop Non-Fees
Commission for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant requests the above-identified application to be re-examined in view of the following amendments and remarks:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Director of Patents, PO Box 1450, Alexandria, VA 22313-1450, on 6 October 2003.